

Attorney's Docket No.: 10-117-006001 / S21-118827M/HW

CP-2814
RECEIVED

FEB 28 2000

TECHNOLOGY CENTER/2800

Applicant : Shuichi Kikuchi et al.

Art Unit : Unknown

Serial No. : 09/444,819

Examiner : Unknown

Filed : November 22, 1999

Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Assistant Commissioner for Patents
Washington, D.C. 20231

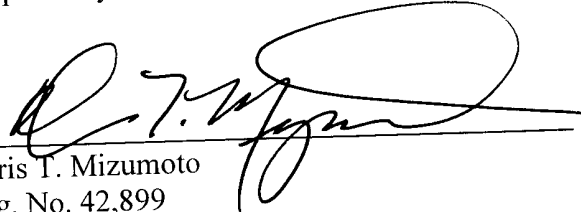
INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449, copies of which are enclosed.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2/18/00


Chris T. Mizumoto
Reg. No. 42,899

Fish & Richardson P.C.
45 Rockefeller Plaza, Suite 2800
New York, NY 10111
Telephone: (212) 765-5070
Facsimile: (212) 258-2291

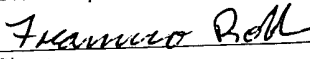
30009719.doc

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

February 18, 2000

Date of Deposit


Signature

Francisco Robles

Typed or Printed Name of Person Signing Certificate

Substitute Form PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark OfficeAttorney's Docket No.
10417-006001Application No.
09/444,819**Information Disclosure Statement**
by Applicant

(Use several sheets if necessary)

(37 CFR §1.98(b))

Applicant
Shuichi Kikuchi et al.Filing Date
November 22, 1999Group Art Unit **5828**

TECHNOLOGY CENTER 2800

U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	JPA-09-139438	May 27, 1997	Japan	H01L	21/8249		x
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.